

Form PTO 1445
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LIST OF REFERENCES CITED BY APPLICANT

ATTY DOCKET NO. 218290US2	SERIAL NO. 10/050,865
APPLICANT Kouichi OHTAKA, et al.	
FILING DATE January 18, 2002	GROUP 2873

COPY

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
AA						
AB						
AC						
AD						
AE						
AF						
AG						
AH						
AI						
AJ						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES	NO
T.T.	AK 6-138403	05/20/94	JAPAN (with English Abstract)	/	X
	AL 7-218845	08/18/95	JAPAN (with English Abstract)	/	X
	AM 2000-2842	01/07/2000	JAPAN (with English Abstract)	/	X
	AN 10-510374	10/06/98	JAPAN (with corr. WO 96/41217)	/	X
	AO WO 96/41217	12/19/96	WIPO	/	
	AP 2941952	08/30/99	JAPAN (with corr. WO 96/41224)	/	X
	AQ WO 96/41224	12/19/96	WIPO	/	
	AR 3016871	03/06/2000	JAPAN (with corr. WO 96/41226)	/	X
T.T.	AS WO 96/41226	12/19/96	WIPO	/	
	AT			/	
	AU				
	AV				

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

T.T.,	AW	K. E. PETERSEN, Applied Physics Letters, vol. 31, no. 8, pages 521-523, "MICROMECHANICAL LIGHT MODULATOR ARRAY FABRICATED ON SILICON", October 15, 1977
T.T.,	AX	O. SOLGAARD, et al., Optics Letters, vol. 17, no. 9, pages 688-690, "DEFORMABLE GRATING OPTICAL MODULATOR", May 1, 1992
T.T.,	AY	Larry J. HORNBECK, SPIE Critical Reviews Series, vol. 1150, pages 86-102, "DEFORMABLE-MIRROR SPATIAL LIGHT MODULATORS", August, 1989
	AZ	

Examiner *Tuyen Tra*Date Considered *5/03/2005*

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.